

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Patent Application of:	)	Group Art Unit: 2812
Akihisa SHIMOMURA et al.	)	Examiner: Stanetta D
Serial No. 10/607,542	)	CERTIFICATE OF I I hereby certify that this contained deposited with the Un Service with sufficient posta
Filed: June 27, 2003	)	

For: METHOD OF MANUFACTURING A

SEMICONDUCTOR DEVICE

xaminer: Stanetta D. Isaac **CERTIFICATE OF MAILING** 

hereby certify that this correspondence is eing deposited with the United States Postal ervice with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 12, 2007.

## **AMENDMENT**

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated March 12, 2007, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 14 of this paper.